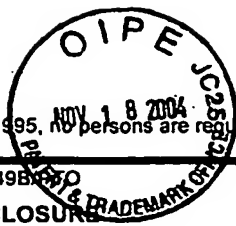


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Substitute for form 1449B-PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> Date Submitted: November 18, 2004 (use as many sheets as necessary)		<b>Complete If Known</b> Application Number: 10/066,582 Filing Date: 2/6/2002 First Named Inventor: JÜRGEN HOFFMANN Group Art Unit: 2878 Examiner Name: T. Luu Attorney Docket Number: 016790-0455	
Sheet	1	of	1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
JAL	B1	6,222,961	B1	ENGELHARDT et al.	04/24/2001	
JAL	B2	2002/0063220	A1	ENGELHARDT et al.	05/30/2002	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
JAL	B3	DE	196 33 185	A1	LEICA LASERTECHNIK	10/23/1997		Abst.
JAL	B4	DE	199 14 049	A1	LEICA MICROSYSTEMS HEIDELBERG GmbH	10/05/2000		Abst.
JAL	B5	DE	100 56 382	A1	LEICA MICROSYSTEMS HEIDELBERG GmbH	05/23/2002		Abst.

NON PATENT LITERATURE DOCUMENTS				
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